

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|-------|---|---|------------------|---------|------------------|
| L2 | 2 | (rotational adj operation adj quantity) and (input adj device) and (rotation adj angle) and (two adj dimensional) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:54 |
| L3 | 0 | ((two adj dimensional) with sensor\$1) and (substrate\$1) and (detection adj electrode\$1) and (elastic adj body) and (conductive adj layer\$1) and (operating adj panel\$1) and (detection adj circuit) and (capacitance adj element\$1) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:58 |
| L4 | 14170 | ((two adj dimensional) with sensor\$1) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:58 |
| L5 | 0 | (substrate\$1) and (detection adj electrode\$1) and (elastic adj body) and (conductive adj layer\$1) and (operating adj panel\$1) and (detection adj circuit) and (capacitance adj element\$1) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:58 |
| L6 | 341 | (elastic adj body) and (conductive adj layer\$1) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:58 |
| L7 | 304 | (detection adj circuit) and (capacitance adj element\$1) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:59 |
| L8 | 0 | 6 and 7 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:59 |

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|-----|----|---------|---|----|----|------------------|
| L9 | 2 | 4 and 6 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:59 |
| L10 | 10 | 4 and 7 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:59 |

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|-------|------|--|---|------------------|---------|------------------|
| L1 | 0 | ((rotational adj operation adj quantity) with (input adj device) with (rotation adj angle) and (two adj dimensional) adj (force\$1) with (xy adj coordinate\$1) with (rectangular adj coordinate\$1) and (polar adj coordinate\$1) adj (convert\$3) with (sequential\$2 adj converting) with (series) with (polar adj coordinate\$1) and (operation adj quantity adj recognizing) with (variation adj angle) with (coordinate adj angle\$1) with (rotation adj angle) and (two adj dimensional) adj (force) adj (sensor\$1) and (substrate adj upper adj surface) with (xy adj 2D adj rectangular adj coordinate\$1) with (x adj axis) adj (intersect\$3) adj (upper surface) with (y adj axis) adj (intersect\$3) adj (upper surface) and (detection adj electrode\$1) adj (upper adj surface) and (outer adj electrode\$1) adj (upper adj surface) adj (detection adj electrode\$1) and (elastic adj deformable adj body) adj (substrate) with (detection adj electrode\$1) with (outer adj electrode\$1) and (displacement adj conductive adj layer\$1) adj (lower adj surface) with (elastic adj deformable adj body) and (plrality adj capacitance adj element\$1) adj (detection adj electrode\$1) with (displacement adj conductive layer\$1) and (operating adj panel) adj (upper adj surface) with (elastic adj deformable adj body) and (detection adj circuit) with (coordinate\$1 adj xy) with (capacitane adj value\$1) with (detection adj capacitance adj element\$1) and (displacement adj conductive adj layer\$1) adj contact adj (outer adj electrode\$1)).clm. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/02/04 22:50 |